Electronic Pate	ent App	lication Fee	Transm	ittal			
Application Number:	105	10598502					
Filing Date:	01-	01-Sep-2006					
Title of Invention:		SPUTTERING TARGET WITH FEW SURFACE DEFECTS, AND SURFACE PROCESSING METHOD THEREOF					
First Named Inventor/Applicant Name:	Yui	Yuichiro Nakamura					
Filer:	Wil	William Bak/Bea Houwen					
Attorney Docket Number:	OG	OGOSH60USA					
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Fi	iling Fee	5					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:					1		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Utility Applissue fee		1501	1	1510	1510		

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1810